



Attorney Docket No. UMC-96-279 CON  
Client Matter No. 81848.0016.001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of:

Chih-Chien LIU, et al.

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA  
CHEMICAL VAPOR  
DEPOSITION PROCESS

Art Unit: 1711

Examiner: Rabon A. SERGENT

RECEIVED  
FEB 19 2003  
TC 1700

CERTIFICATE OF MAILING BY EXPRESS MAIL

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

The undersigned hereby certifies that the attached:

1. IDS and Form PTO/SB/08A with references;
2. Check for \$180.00;
2. Certificate of Mailing by Express Mail; and
3. Return postcard

relating to the above application, were deposited as "Express Mail," Mailing Label No. EL533454277US with the U.S. Postal Service, addressed to Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231, on February 10, 2003.

February 10, 2003

  
\_\_\_\_\_  
Maller

February 10, 2003

  
\_\_\_\_\_  
Jed W. Caven, Reg. No. 40,551  
HOGAN & HARTSON LLP  
1200 17<sup>th</sup> Street, Suite 1500  
Denver, Colorado 80202  
Telephone: (303) 454-2432  
Facsimile: (303) 899-7333



Attorney Docket No. UMC-96-279 CON  
Client/Matter No. 81848.0016.001

#28/8/3  
3/2/10

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of:

Chih-Chien LIU, et al.

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA  
CHEMICAL VAPOR  
DEPOSITION PROCESS

Group Art Unit: 1711

Examiner: Rabon A. SERGENT

RECEIVED  
FEB 19 2003  
TC 1700

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. 1.97

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant hereby submits for filing under 37 CFR 1.97 a disclosure statement. In submitting these references, no representation is made or implied that the references are or are not material to the examination of this application. The patents, publications or other information of which Applicant is presently aware are listed in Form PTO/SB/08A submitted herewith and copies of all such patents and publications are attached hereto.

This Information Disclosure Statement is being filed pursuant to 37 CFR 1.97(c). A check to cover the fee set forth in 1.17(p) is enclosed herewith. Any fee deficiency associated with this submittal may be charged to Deposit Account No. 50-1123.

02/13/2003 SDENBDB1 00000078 09546174

01 FC:1806

180.00 DP

Signed on February 10, 2003.

Respectfully submitted,

  
Jed W. Caven, #40551  
HOGAN & HARTSON LLP  
One Tabor Center  
1200 17th Street, Suite 1500  
Denver, Colorado 80202  
(303) 454-2432  
(303) 899-7333 Fax

RECEIVED  
FEB 19 2003  
TC 1700